AN



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77851

Hiroo TAKIZAWA, et al.

Appln. No.: 10/678,301

Group Art Unit: 1756

Confirmation No.: 4148

Examiner: Not Yet Assigned

Filed: October 06, 2003

For:

NON-RESONANT TWO-PHOTON ABORBING MATERIAL, NON-RESONANT

TWO-PHOTON EMITTING MATERIAL, AND METHOD FOR INDUCING ABSORPTION OR GENERATING EMISSION OF NON-RESONANT TWO

PHOTONS BY USING THE MATERIAL

STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned respectfully requests to be advised of the status of the above-identified application.

Respectfully submitted,

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